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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
10/067,309	02/07/2002	Hiroshi Ito	219387US2S	7066
22850 75	590 10/22/2003		EXAMINER	
OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C. 1940 DUKE STREET			WONG, EDNA	
ALEXANDRIA			ART UNIT PAPER NUMBE	
			. 1753	
			DATE MAILED, 10/22/2002	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)				
	Office Action Summary	10/067,309	ITO, HIROSHI				
	- Cince Action Guilliary	Examiner	Art Unit				
	The MAILING DATE of this communication app	Edna Wong	1753				
Period fo	or Reply	ears on the cover sneet with the	correspond nce address				
THE I - Externanter - If the - If NO - Failu - Any r	ORTENED STATUTORY PERIOD FOR REPLY MAILING DATE OF THIS COMMUNICATION. Insions of time may be available under the provisions of 37 CFR 1.13 SIX (6) MONTHS from the mailing date of this communication. Period for reply specified above is less than thirty (30) days, a reply period for reply is specified above, the maximum statutory period we re to reply within the set or extended period for reply will, by statute, eply received by the Office later than three months after the mailing indicated part of the patent term adjustment. See 37 CFR 1.704(b).	6(a). In no event, however, may a reply be ti within the statutory minimum of thirty (30) da ill apply and will expire SIX (6) MONTHS fror cause the application to become ABANDON	imely filed ys will be considered timely. the mailing date of this communicati ED (35 U.S.C. § 133).	on.			
1)	Responsive to communication(s) filed on						
2a) <u></u>		s action is non-final.					
3)□	_						
Dispositi	on of Claims	ex parte quayre, 1000 C.D. 11,	400 O.O., 210.				
4)🖂	Claim(s) 1-20 is/are pending in the application						
	4a) Of the above claim(s) is/are withdraw	n from consideration.					
5)□	Claim(s) is/are allowed.		·				
6)□	Claim(s) is/are rejected.	•					
7)	Claim(s) is/are objected to.						
	Claim(s) 1-20 are subject to restriction and/or e	lection requirement.					
	on Papers						
	The specification is objected to by the Examiner						
10)[_]	The drawing(s) filed on is/are: a)☐ accep						
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a). 11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner.							
11)[oved by the Examiner.				
If approved, corrected drawings are required in reply to this Office action.							
	The oath or declaration is objected to by the Exa	aminer.					
_	nder 35 U.S.C. §§ 119 and 120			•			
	Acknowledgment is made of a claim for foreign	priority under 35 U.S.C. § 119(a	a)-(d) or (f).				
a)L	☐ All b)☐ Some * c)☐ None of:		•				
	1. Certified copies of the priority documents						
	2. Certified copies of the priority documents						
	 Copies of the certified copies of the priori application from the International Bur ee the attached detailed Office action for a list of 	eau (PCT Rule 17.2(a)).					
14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).							
a) ☐ The translation of the foreign language provisional application has been received. 15)☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.							
Attachment		Priority under 33 U.S.C. 99 120	∪ anu/UI 1∠1.				
1) Notice	e of References Cited (PTO-892) of Draftsperson's Patent Drawing Review (PTO-948)	5) Notice of Informal	ry (PTO-413) Paper No(s) Patent Application (PTO-152)				
J L Intorn	nation Disclosure Statement(s) (PTO-1449) Paper No(s)	6)					



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Election/Restrictions

Restriction to one of the following inventions is required under 35 U.S.C. 121:

- Claims 1-10, drawn to a laser processing method for irradiating a mask with a plurality of openings formed therein with a pulse laser, and irradiating a plurality of portions of a work to be processed with said pulse laser transmitted through said plurality of openings at the same time, classified in class 204, subclass 157.15.
- II. Claims 11-20, drawn to a laser process apparatus for irradiating a mask with a plurality of openings formed therein with a pulse laser, and irradiating a plurality of portions of a work to be processed with said pulse laser transmitted through said plurality of openings at the same time, classified in class 422, subclass 186.

The inventions are distinct, each from the other because of the following reasons:

Inventions I and II are related as process and apparatus for its practice. The
inventions are distinct if it can be shown that either: (1) the process as claimed can be

practiced by another materially different apparatus or by hand, or (2) the apparatus as

claimed can be used to practice another and materially different process. (MPEP §

806.05(e)). In this case the apparatus as claimed can be used to practice another and

materially different process such as a laser etching process.

Because these inventions are distinct for the reasons given above and have acquired a separate status in the art as shown by their different classification, restriction

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for examination purposes as indicated is proper.

Because these inventions are distinct for the reasons given above and the search required for Group I is not required for Group II, restriction for examination purposes as indicated is proper.

Applicant is advised that the reply to this requirement to be complete must include an election of the invention to be examined even though the requirement be traversed (37 CFR 1.143).

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Edna Wong whose telephone number is (703) 308-3818. The examiner can normally be reached on Mon-Fri 7:30 am to 5:00 pm, alt. Fridays off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nam Nguyen can be reached on (703) 308-3322. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-1495.

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Edna Wong)
Primary Examiner
Art Unit 1753

EW October 18, 2003